

## Contents

**Preface** XVII

**List of Contributors** XIX

- 1 Introduction to Plasmas** 1  
*Hideo Ikegami*
- 1.1 Plasmas 1
- 1.1.1 Plasma Characteristics 1
- 1.2 Discharge Plasmas 3
- 1.2.1 Glow Plasma 3
- 1.2.2 Atmospheric Plasmas 4
- References 5
- 2 Environmental Application of Nonthermal Plasma** 7  
*Akira Mizuno*
- 2.1 Introduction 7
- 2.2 Generation of Atmospheric Nonthermal Plasma 7
- 2.3 Indoor Air Cleaning System Using Plasma and Catalyst  
Combination 9
- 2.4 Diesel Exhaust Cleaning 12
- 2.5 Interaction of Atmospheric Plasma with Liquid 14
- 2.6 Concluding Remarks 16
- References 16
- 3 Atmospheric Plasma Air Pollution Control, Solid Waste, and Water  
Treatment Technologies: Fundamental and Overview** 19  
*Jen-Shih Chang*
- 3.1 Introduction 19
- 3.1.1 Nonthermal Plasma Air Pollution Control 19
- 3.1.2 Thermal Plasma Solid Waste Treatment 20
- 3.1.3 Electrohydraulic Water Treatment 21
- 3.2 Type of Plasmas 21
- 3.3 Plasma Chemistry 23

3.4	Plasma Reactor	24
3.4.1	Nonthermal Plasma Reactor	24
3.4.2	Thermal Plasma Reactors	25
3.4.3	Electrohydraulic Discharge	26
3.5	Determination of Plasma Parameters and the Other Phenomena	29
3.6	Engineering and Economics	30
3.6.1	Nonthermal Plasma Pollution Control	30
3.6.2	Thermal Plasma Solid Waste and Water Treatment	32
3.7	Concluding Remarks	32
	References	34
<b>4</b>	<b>Optical Diagnostics for High-Pressure Nonthermal Plasma Analysis</b>	<b>37</b>
	<i>Tetsuji Oda and Ryo Ono</i>	
4.1	Introduction	37
4.2	Experimental Examples	38
4.2.1	Optical Emission Photograph	38
4.2.2	Optical Emission Spectra	39
4.2.3	Laser-Induced Fluorescence (LIF)	39
4.2.3.1	OH Radical	39
4.2.4	LIF of Atomic Oxygen Radical	41
4.2.5	LIF of NO Molecule	41
4.2.6	N <sub>2</sub> (A) LIF in the Plasma	41
4.2.7	O <sub>2</sub> LIF	43
4.2.8	Optical Absorption	45
4.3	Conclusions	47
	References	47
<b>5</b>	<b>Laser Investigations of Flow Patterns in Electrostatic Precipitators and Nonthermal Plasma Reactors</b>	<b>49</b>
	<i>Jerzy Mizeraczyk, Janusz Podlinski, Anna Niewulis, and Mirosław Dors</i>	
5.1	Introduction	49
5.2	PIV Experimental Setups	50
5.3	Results—PIV Measurements	51
5.3.1	3D EHD Flow in Wide ESP with (Transverse) Wire-Plate Electrode System	51
5.3.2	3D EHD Flow in Wide ESP with (Transverse) Spike-Plate Electrode System	53
5.3.3	3D EHD Flow in Narrow ESP with Transverse Wire-Plate Electrode System	56
5.3.4	3D EHD Flow in Narrow ESP with Longitudinal Wire-Plate Electrode System	58
5.3.5	EHD Flow in Nonthermal Plasma Reactor for Water Treatment	60
5.4	Conclusions	62
	Acknowledgment	63
	References	63

## **6 Water Plasmas for Environmental Application 65**

*Takayuki Watanabe*

6.1	Introduction	65
6.2	Water Plasma Generation and Its Characteristics	66
6.2.1	Water Plasma Generation	66
6.2.2	Temperature Measurements	68
6.3	Decomposition of Halogenated Hydrocarbons	69
6.3.1	Thermodynamic Consideration	70
6.3.2	Experimental Setups	72
6.3.3	Experimental Results	73
6.4	Conclusion	75
	References	76

## **7 Chemistry of Organic Pollutants in Atmospheric Plasmas 79**

*Ester Marotta, Milko Schiorlin, Massimo Rea, and Cristina Paradisi*

7.1	Introduction	79
7.2	Experimental	80
7.2.1	Chemicals	80
7.2.2	Experiments with the Corona Reactor	81
7.2.3	Analysis of Ions	82
7.3	Results and Discussion	82
7.4	Conclusions	90
	Acknowledgments	91
	References	91

## **8 Generation and Application of Wide Area Plasma 93**

*Noureddine Zouzou, Kazunori Takashima, Akira Mizuno, and Gerard Touchard*

8.1	Introduction	93
8.2	AirFlow Control	93
8.3	Aerodynamic Plasma Actuators	95
8.4	Particle Destruction	97
8.5	Large Sliding Discharge	98
8.6	Conclusion	103
	References	103

## **9 Nonthermal Plasma-based System for Exhaust Treatment under Reduced Atmosphere of Pyrolysis Gases 105**

*Marcela Morvová, Viktor Martišoviš, Imrich Morva, Ivan Košinár, Mário Janda, Daniela Kunecová, Nina Kolesárová, Veronika Biskupiřová, and Marcela Morvová Jr*

9.1	Introduction	105
9.2	Experimental	106
9.3	Results	107
9.4	Conclusions	110

Acknowledgments 111

References 111

## 10 **Pharmaceutical and Biomedical Engineering by Plasma Techniques** 113

*Masayuki Kuzuya, Yasushi Sasai, Shin-ichi Kondo, and Yukinori Yamauchi*

10.1 Introduction 113

10.2 Nature of Plasma-Induced Polymer Radicals 114

10.3 Pharmaceutical Engineering for DDS Preparation by Plasma Techniques 118

10.3.1 Preparation of Sustained-Release DDS from Plasma-Irradiated DC Tablets 118

10.3.2 Preparation of Time-Controlled Drug Release System by Plasma Techniques 122

10.3.3 Preparation of Intragastric FDDS by Plasma Techniques 123

10.3.4 Patient-Tailored DDS for Large Intestine Targeted-Release Preparations 125

10.3.5 Preparation of Functionalized Composite Powders Applicable to Matrix-Type DDS 128

10.4 Biomedical Engineering by Plasma Techniques 129

10.4.1 Preparation of Clinical Catheter with Durable Surface Lubricity 130

10.4.2 Improvement of Cell Adhesion by Immobilizing VEMAC on Polymer Surface 131

10.4.3 Plasma-Assisted Immobilization of Biomolecules onto Polymer Surfaces 132

10.4.4 Basic Study on Preparation of Functionalized PVA-PAANa Hydrogel for Chemoembolic Agent 135

10.5 Conclusion 136

Acknowledgments 137

References 137

## 11 **Targeting Dendritic Cells with Carbon Magnetic Nanoparticles Made by Dense-Medium Plasma Technology** 141

*Heidi A. Schreiber, Jozsef Prechl, Hongquan Jiang, Alla Zozulya, Zsuzsanna Fabry, Ferencz S. Denes, and Matyas Sandor*

References 146

## 12 **Applications of Pulsed Power and Plasmas to Biosystems and Living Organisms** 149

*Hidenori Akiyama, Sunao Katsuki, and Masahiro Akiyama*

12.1 Introduction 149

12.2 Pulsed-Power Source Using Magnetic Pulse Compression System 149

12.3 Discharge Plasmas by Pulsed Power 151

12.3.1 Large Volume Discharge Plasmas in Atmospheric Gases 151

12.3.2 Large Volume Discharge Plasmas in Water 153

12.4 Action of Pulsed Power and Discharge Plasma to Biosystems 158

12.4.1 Action of Pulsed Power to Biosystems 158

12.4.2 Cleaning of Lakes and Dams 160

12.5 Summary 161

References 162

## 13 **Applications of Plasma Polymerization in Biomaterials** 165

*David A. Steele and Robert D. Short*

13.1 Introduction 165

13.2 Example 1: Improving Surfaces for Blood Biocompatibility 168

13.3 Example 2: Foreign Body Response 170

13.4 Example 3: Extended Wear Contact Lenses 173

13.5 Example 4: Platform for Immobilizing a Biomolecule 174

13.6 Example 5: An Improved Surface Plasmon Resonance Biosensor 177

13.7 Conclusions 178

References 178

## 14 **Plasma Sterilization at Normal Atmospheric Pressure** 181

*Tetsuya Akitsu, Siti Khadijah Za aba, Hiroshi Ohkawa, Keiko Katayama-Hirayama, Masao Tsuji, Naohiro Shimizu, and Yuichirou Imanishi*

14.1 Introduction 181

14.2 Experimental Schemes 182

14.2.1 Inductive Energy Storage Pulse-Power Source 182

14.2.2 Antibacterial Test 184

14.3 Experimental Result 185

14.4 Conclusion 188

Acknowledgments 191

References 191

## 15 **Elimination of Pathogenic Biological Residuals by Means of Low-Pressure Inductively Coupled Plasma Discharge** 193

*Ondřej Kylián, Hubert Rauscher, Ana Ruiz, Benjamin Denis, Katharina Stapelmann, and François Rossi*

15.1 Introduction 193

15.2 Experimental 194

15.2.1 Plasma Treatment 194

15.2.2 Samples Preparation and Evaluation of the Effect of a Plasma Treatment 194

15.3 Results 196

15.3.1 Bacterial Spores 196

15.3.2 Homopolymers of Amino Acids 197

15.4	Conclusions 197 Acknowledgments 198 References 199	19.3.1	H <sub>2</sub> Plasma Characteristics 238
		19.3.2	SiH <sub>4</sub> /H <sub>2</sub> Plasma Characteristics 241
		19.4	Summary 244 References 245
<b>16</b>	<b>Sterilization and Protein Treatment Using Oxygen Radicals Produced by RF Discharge 201</b> <i>Nobuya Hayashi and Akira Yonesu</i>	<b>20</b>	<b>Deposition of a-Si : H Films with High Stability against Light Exposure by Reducing Deposition of Nanoparticles Formed in SiH<sub>4</sub> Discharges 247</b> <i>Kazunori Koga, Masaharu Shiratani, and Yukio Watanabe</i>
16.1	Introduction 201	20.1	Introduction 247
16.2	Experimental Procedure 201	20.2	Formation Mechanism of Nanoparticles in Silane Discharges 248
16.3	Generation of Oxygen Radicals 202	20.3	Contribution of Higher Order Silane Molecules and Nanoparticles to SiH <sub>2</sub> Bond Formation in Films 250
16.4	Sterilization of Medical Equipments 203	20.4	Effects of Nanoparticles on a-Si : H Qualities 252
16.5	Decomposition of Protein's Structure 204 References 206	20.5	High Rate Deposition of a-Si : H Films of High Stability against Light Exposure Using Multihollow Discharge Plasma CVD 254
		20.6	Conclusions 256 Acknowledgments 256 References 256
<b>17</b>	<b>Hydrophilicity and Bioactivity of a Polyethylene Terephthalate Surface Modified by Plasma-Initiated Graft Polymerization 207</b> <i>Nagahiro Saito, Takahiro Ishizaki, Junko Hieda, Syohei Fujita, and Osamu Takai</i>	<b>21</b>	<b>Diagnostics and Modeling of SiH<sub>4</sub>/H<sub>2</sub> Plasmas for the Deposition of Microcrystalline Silicon: the Case of Dual-Frequency Sources 259</b> <i>Eleftherios Amanatides and Dimitrios Mataras</i>
17.1	Introduction 207	21.1	Introduction 259
17.2	Experimental 208	21.2	Experimental 260
17.2.1	Materials 208	21.3	Model Description 261
17.2.2	Surface Modification 208	21.4	Results and Discussion 262
17.2.3	Surface Characterization 209	21.5	Conclusions 271 Acknowledgments 272 References 272
17.2.4	Cell Culture 209		
17.3	Results and Discussion 209	<b>22</b>	<b>Introduction to Diamond-Like Carbons 275</b> <i>Masaru Hori</i>
17.4	Conclusions 218 References 218	<b>23</b>	<b>Diamond-Like Carbon for Applications 277</b> <i>John Robertson</i>
<b>18</b>	<b>Strategies and Issues on the Plasma Processing of Thin-Film Silicon Solar Cells 221</b> <i>Akihisa Matsuda</i>	23.1	Introduction 277
18.1	Introduction 221	23.2	Growth Rates 277
18.2	Growth Process of a-Si : H and $\mu$ c-Si : H by PECVD 221	23.3	Basic Properties 281
18.3	Growth of High-Quality a-Si : H 223	23.4	Stress 284
18.4	Concept of Protocrystal a-Si : H (Stable a-Si : H) 226	23.5	Applications of DLC 286
18.5	Growth of High-Quality $\mu$ c-Si : H 228	23.6	MEMs 291
18.6	Summary 229 References 229	23.7	Electronic Applications 292
<b>19</b>	<b>Characteristics of VHF Plasma with Large Area 231</b> <i>Yoshinobu Kawai, Yoshiaki Takeuchi, Yasuhiro Yamauchi, and Hiromu Takatsuka</i>	23.8	Bioactive Surfaces 294
19.1	Introduction 231	23.9	Conclusions 296
19.2	Development of Balanced Power Feeding Method 232		
19.3	Characteristics of VHF Plasma 238		

	Acknowledgments	297			
	References	297			
<b>24</b>	<b>Applications of DLCs to Bioprocessing</b>	<b>301</b>			
	<i>Tatsuyuki Nakatani and Yuki Nitta</i>				
24.1	Introduction	301			
24.2	High-Tenacity DLC Tin Films for Stents	303			
24.3	Applications of DLC Films to Coronary Drug-Eluting Stent	305			
24.4	DLC Films with Controlled Zeta Potential of Biomaterials	306			
24.5	Characterization of Biomimetic DLC and <i>In vitro</i> Biocompatibility Evaluation	308			
24.5.1	Biomimetic DLC and Blood Compatibility	309			
24.5.2	Biomimetic DLC and Cytocompatibility	309			
24.6	Conclusion	312			
	Acknowledgments	313			
	References	313			
<b>25</b>	<b>Plasma Processing of Nanocrystalline Semiconductive Cubic Boron Nitride Thin Films</b>	<b>315</b>			
	<i>Kenji Nose and Toyonobu Yoshida</i>				
25.1	Introduction	315			
25.2	Fundamental Properties of cBN	316			
25.2.1	Physical Properties	316			
25.2.2	Electronic Properties	317			
25.2.3	Intrinsic Electronic State	317			
25.2.3.1	Self-Defects	318			
25.2.3.2	Dopants	318			
25.3	Growth of cBN Thin Films	319			
25.3.1	Process and Structure	319			
25.3.1.1	Plasma Processing of cBN Thin Film	319			
25.3.1.2	Initial Layer Growth	320			
25.3.1.3	Nucleation and Growth of Cubic Phase	321			
25.3.2	Approaches to Epitaxial Growth	322			
25.3.2.1	For Direct Growth on Silicon	322			
25.3.2.2	Epitaxy on Diamond	322			
25.4	Doping Processes and Electrical Characterization	323			
25.4.1	In situ Doping Process	323			
25.4.1.1	Doping by Sputtering of Bulk Sources	323			
25.4.1.2	Effects of Doping on Nucleation and Growth	325			
25.4.2	Electrical Properties of Doped cBN Films	327			
25.4.2.1	Silicon-Doped Films	327			
25.4.2.2	Beryllium-Doped Films	328			
25.4.2.3	Zinc-Doped Films	329			
25.4.2.4	Magnesium-Doped Films	331			
25.5	Conclusion	331			
	References	332			
<b>26</b>	<b>Fundamentals on Tribology of Plasma-Deposited Diamond-Like Carbon films</b>	<b>335</b>			
	<i>Julien Fontaine and Christophe Donnet</i>				
26.1	Introduction	335			
26.2	Special Case of DLC Coatings	335			
26.3	Superlubricity of DLC Coatings	336			
26.4	Conclusion	337			
	References	337			
<b>27</b>	<b>Diamond-Like Carbon Thin Films Grown in Pulsed-DC Plasmas</b>	<b>339</b>			
	<i>Enric Bertran, Miguel Rubio-Roy, Carles Corbella, and José-Luis Andújar</i>				
27.1	Introduction	339			
27.2	Experimental Details	340			
27.3	Results and Discussion	342			
27.4	Conclusions	347			
	Acknowledgments	347			
	References	347			
<b>28</b>	<b>Plasma Deposition of N-TiO<sub>2</sub> Thin Films</b>	<b>349</b>			
	<i>Pablo Romero-Gómez, Angel Barranco, José Cotrino, Juan P. Espinós, Francisco Yubero, and Agustín R. González-Elípe</i>				
28.1	Introduction	349			
28.2	Experimental Setup and Diagnostic Techniques	350			
28.3	Results and Discussion	351			
	Acknowledgments	355			
	References	355			
<b>29</b>	<b>Investigation of DLC and Multilayer Coatings Hydrophobic Character for Biomedical Applications</b>	<b>357</b>			
	<i>Rodica Vladoiu, Aurelia Mandes, Virginia Dinca, Mirelsa Contulov, Victor Ciupina, Cristian Petric Lungu, and Geavit Musa</i>				
29.1	Introduction	357			
29.2	Experimental Setup	358			
29.3	Results and Discussions	360			
29.4	Conclusions	362			
	Acknowledgments	363			
	References	363			
<b>30</b>	<b>Creation of Novel Electromagnetic and Reactive Media from Microplasmas</b>	<b>365</b>			
	<i>Kunihide Tachibana</i>				
30.1	Introduction	365			

30.2	Microplasma in Single Use as Plasma Jet	367
30.3	Microplasma Integration for Large-Area Material Processing	370
30.4	Microplasma Integration for Electromagnetic Media	372
30.5	Concluding Remarks and Perspectives	375
	Acknowledgments	375
	References	375
<b>31</b>	<b>Nanoblock Assembly Using Pulse RF Discharges with Amplitude Modulation</b>	<b>377</b>
	<i>Shinya Iwashita, Hiroshi Miyata, Kazunori Koga, and Masaharu Shiratani</i>	
31.1	Introduction	377
31.2	Formation of Nanoblocks and Their Agglomeration	378
31.3	Assembly of Nanoblocks in Gas Phase Using Agglomeration	379
31.4	Conclusions	382
	Acknowledgments	382
	References	383
<b>32</b>	<b>Thomson Scattering Diagnostics of Discharge Plasmas</b>	<b>385</b>
	<i>Kiichiro Uchino and Kentaro Tomita</i>	
32.1	Introduction	385
32.2	Application to Low-Pressure Plasmas	386
32.3	Diagnostics of PDP Plasmas	387
32.3.1	LTS Using a Visible System	387
32.3.2	Infrared LTS System	388
32.3.3	Results and Discussion	390
32.3.3.1	Laser Perturbations	390
32.3.3.2	Results of LTS Measurements	392
32.4	Diagnostics of EUV Plasmas	392
32.4.1	Experiment	394
32.4.2	Results and Discussions	395
	References	397
<b>33</b>	<b>Crystallized Nanodust Particles Growth in Low-Pressure Cold Plasmas</b>	<b>399</b>
	<i>Laiifa Boufendi, Marie Christine Jouanny, Marjory Cavarroc, Abdelaziz Mezeghrane, Maxime Mikikian, and Yves Tessier</i>	
33.1	Introduction	399
33.2	Description of the Experimental Setup	400
33.3	Detection of Nanocrystallites Formation in the Plasma Gas Phase	401
33.4	Atomic Structure of the Nanocrystallites	402
33.5	Size and Crystalline Volume Fraction Measurements	404
33.6	Gas Temperature Effects on Dust Nanoparticle Nucleation and Growth	406

33.7	Conclusion	407
	References	408

## **34 Collection and Removal of Fine Particles in Plasma Chambers** 409

*Noriyoshi Sato*

34.1	Introduction	409
34.2	NFP-collector	410
34.3	Ditch Guidance	414
34.4	Plate Cleaning	417
34.5	Effects on Particles Produced in Plasmas	419
34.6	Conclusions	422
	Acknowledgments	422
	References	422

## **Index** 425